

Notice of References Cited	Application/Control No. 10/643,987		Applicant(s)/Patent Under Reexamination AHERN ET AL.	
	Examiner Neil R. Kardos		Art Unit 3623	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,115,691 A	09-2000	Ulwick, Anthony W.	705/7
*	B	US-2001/0034686 A1	10-2001	Eder, Jeff Scott	705/36
*	C	US-6,393,406 B1	05-2002	Eder, Jeff	705/7
*	D	US-6,411,936 B1	06-2002	Sanders, Aaron M.	705/10
*	E	US-6,546,545 B1	04-2003	Honarvar et al.	717/100
*	F	US-2003/0088456 A1	05-2003	Ernest et al.	705/10
*	G	US-2003/0120533 A1	06-2003	Popillo et al.	705/9
*	H	US-2003/0158800 A1	08-2003	Pisello et al.	705/35
*	I	US-2004/0034552 A1	02-2004	Cole et al.	705/7
*	J	US-2004/0148566 A1	07-2004	Jaffar et al.	715/503
*	K	US-2005/0086091 A1	04-2005	Trumbly et al.	705/007
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.